

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

792/a
11/27/01
Chandler

Applicant(s): Halahan, Patrick B.; Siniaguine, Oleg

Assignee: Tru-Si Technologies, Inc.

Title: Semiconductor Structures Having Multiple Conductive Layers In An Opening, And Methods For Fabricating Same

Serial No.: Not yet known

Filing Date:

Examiner: Not yet known

Group Art Unit: Not yet known

Docket No.: M-9999-1D US

San Jose, California
August 28, 2001

Box Patent Application
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above-identified application as follows.

IN THE SPECIFICATION

On page 1, before line 6, please insert the following paragraphs:

CROSS-REFERENCE TO RELATED APPLICATIONS

a'
The present application is a division of U.S. patent application no. 09/792,311 filed February 22, 2001, incorporated herein by reference.

IN THE CLAIMS

Please cancel Claims 13-19 and 23-29 without prejudice.

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP
25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 453-9200
FAX (408) 453-7979